02

Total No. of Questions: 08

## M.Tech.(VLSI D) EL-I (2016 & Onwards) (Sem.-2) SEMICONDUCTOR DEVICES

Subject Code: MTVL-206 M.Code: 74262

Time: 3 Hrs. Max. Marks: 100

## **INSTRUCTIONS TO CANDIDATES:**

- 1. Attempt any FIVE questions out of EIGHT questions.
- 2. Each question carries TWENTY marks.
- 1. a) What is the physical meaning of schrodinger's wave function? Enlist the applications of it. Discuss **any one** in detail.
  - b) State and derive the continuity equation for electrons.
- 2. a) Describe the Hall Effect. Explain, why polarity of Hall voltage changes depending upon the type of semiconductor.
  - b) What do you understand by linearly graded junction? Discuss its function to obtain special p-n junction capacitance characteristics.
- 3. a) Write a short note on following:
  - i) Avalanche process
  - ii) Early effect
  - b) What is the importance of Gummel Poon model? Discuss the operation of transistor using this model.
- 4. a) Discuss the I-V characteristics of MOSFET when biased in saturation and non-saturation region.
  - b) What do you understand by flat band voltage? Explain the charge distribution of MOS structure for flat band voltage.

**1** M-74262 (S27)-2094

- 5. a) Enlist and describe **any five** short channel effects while obtaining higher integration density in MOSFETS.
  - b) Describe induced drain leakage using band diagram as a function of depth in region where gate overlaps the drain junction.
- 6. a) Explain energy band diagram of MOS capacitor in accumulation and depletion region.
  - b) Explain briefly:
    - i) Work function difference for n<sup>+</sup> polysilicon on silicon as doping is varied.
    - ii) Effects of charges in oxide.
- 7. a) What do you mean by sub-threshold conduction? Discuss the equivalent circuit of MOS showing sub-threshold slope.
  - b) Enlist the parameters that can be determined using C-V characteristics of MOS device. Also discuss effect of temperature on C-V characteristics of MOS device with appropriate diagrams.
- 8. Discuss following briefly:
  - a) Punch through in MOS devices
  - b) High injection effects in BJT
  - c) Channel length modulation
  - d) Transport phenomenon in Nano devices

NOTE: Disclosure of Identity by writing Mobile No. or Making of passing request on any page of Answer Sheet will lead to UMC against the Student.

**2** M-74262 (S27)-2094